

U.S.S.N. 10,656,584

RECEIVED
CENTRAL FAX CENTER
JUL 26 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hsu et al.

Group Art Unit: 1765

Serial No.: 10,656,584

Examiner: Tran, Binh X

Filed: 09/04/2003

In Response to Office Action

Dated: 04/27/2005

For: PLASMA TREATMENT METHOD TO REDUCE SILICON
EROSION OVER HDT SILICON REGIONS

Attorney Docket No.: 67,200-1117

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certified that this correspondence is (1) ☐ being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on July __, 2005; or (2) ☒ being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571) 273-8300 on July 26, 2005.

Randy W. Tung
Printed Name
Signature7/26/05
Date

Please forward all correspondence to
TUNG & ASSOCIATES
838 W. Long Lake Road, Suite 120
Bloomfield Hills, MI 48302

BEST AVAILABLE COPY

1

received 76 pgs out
of 33

RECEIVED
CENTRAL FAX CENTER

JUL 26 2005

U.S.S.N. 10,656,584

RESPONSE TO OFFICE ACTION

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 04/27/2005,
please enter the following amendments and consider the following
remarks.